PATENT

ney Docket No. 5308-278

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Ryu et al.

JUL 1 5 2004

ETRADEMISERIAL No.: 10/731,860

Group Art Unit: 2811 Confirmation No.: 4232

Filed: December 9, 2003

For:

MULTIPLE FLOATING GUARD RING EDGE TERMINATION FOR SILICON

CARBIDE DEVICES AND METHODS OF FABRICATING SILICON CARBIDE

DEVICES INCORPORATING SAME

Date: July 12, 2004

Mail Stop Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT UNDER 37 C.F.R. § 1.97(b)

Sir:

Attached is a Supplemental Form PTO-1449 listing documents cited in the International Search Report for the corresponding International Application Number PCT/US2004/001183. Each document listed on the attached PTO-1449 was first cited in a communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of this Statement. A copy of any listed foreign patent document and/or non-patent literature, including the Search Report, is enclosed.

A copy of any listed U.S. patent and/or U.S. patent application publication is not provided herewith in accordance with the waiver by the U.S. Patent and Trademark Office of requirements under 37 C.F.R. § 1.98(a)(2)(i) for all U.S. national patent applications filed after June 30, 2003 and for all international applications that have entered the national stage under 35 USC § 371 after June 30, 2003.

This Information Disclosure Statement is submitted in accordance with 37 C.F.R. § 1.97(b), within three months of the filing date of the above-referenced application or before the mailing of a first Office Action on the merits, whichever event occurs last. Therefore, no fee is believed due. However, the Commissioner is hereby authorized to charge any deficiency or credit any overpayment to Deposit Account No. 50-0220.

Respectfully submitted,

Timothy J. O'Sullivan

Registration No. 35,632

Customer No. 20792

Certificate of Mailing under 37 CFR 1.8

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to: Commissioner for Patents, PO Box 1450, Alexandria, VA 22313-1450 on July

Traci A Brown

		_						
	T OF	49 U.S. Department of the U.S. Department and Tradema	ark Office ITED BY A	PPLICANT	· Attorney Docket Number 5308-278			Serial No. 10/731,860
JUL 1 5 2004 FINAL TRADEMINING					Applicants: Ryu et al.			
					Filing Date: December 9, 2003			Group: 2811
U. S. PATENT DOCUMENTS								
Examiner Initial		Document Number Date Nam		Name		Class	Subclass	Filing Date if Appropriate
	1.	5,994,189	11/30/99	Akiyama		438	268	
FOREIGN PATENT DOCUMENTS								
		Document Number	Date	Country		Class	Subclass	Translation Yes No
	2.	EP1076363A2	2/14/01	EPO				
	3.	JP3147331	6/24/91	JP				Abstract
OTHER DOCUMENTS								
	4.	International Search Report and Written Opinion of the International Searching Authority for corresponding PCT application no. PCT/US2004/001183, mailed July 7, 2004.						
	5.	Onose et al. Over 2000 V FLR Termination Technologies for SiC High Voltage Devices, 12th International Symposium on Power Semiconductor Devices and IC's. Toulousse, France, May 22-25, 2000.						
\								

EXAMINER *EXAMINER

DATE CONSIDERED

Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.